

#29  
Cumulative  
7/12-11-98

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hidehiko KIRA et al.

Serial No. 08/897,953

Filed: July 24, 1997

For: METHOD AND APPARATUS FOR FABRICATING SEMICONDUCTOR DEVICE



Group Art Unit: 2814

Examiner: David E. GRAYBILL

CPA  
(11-6-99)  
NOT ENTER  
12-28-98

RESPONSE UNDER 37 C.F.R. §1.116

- EXPEDITED RESPONSE -  
GROUP ART UNIT 2814

BOX AF

Assistant Commissioner of Patents  
Washington, D. C. 20231

RECEIVED  
98 DEC -9 PM 2:42  
TECHNOLOGY CENTER 800  
December 7, 1998

Sir:

In response to the Office Action dated July 6, 1998, please amend this application  
as follows:

IN THE DRAWINGS:

The applicants respectfully submit herewith a Request for Approval of Drawings  
Corrections along with proposed drawing corrections to Figure 3, marked in red ink.